



Attorney Docket No.: 0756-1998

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#15/B
DEPTAS
2/13/01

In re Patent Application of
Shunpei YAMAZAKI et al.

Art Unit: 2823

Serial No.: 09/352,194

Examiner: F. Toledo

Filed: July 13, 1999

CERTIFICATE OF MAILING

For: CRYSTALLINE SEMICONDUCTOR
THIN FILM, METHOD OF
FABRICATING THE SAME,
SEMICONDUCTOR DEVICE, AND
METHOD OF FABRICATING THE
SAME

I hereby certify that this
correspondence is being deposited with
the United States Postal Service with
sufficient postage as First Class Mail in
an envelope addressed to: Assistant
Commissioner for Patents, Washington,
D.C. 20231, on 1-29-01
Jenna McCallister

AMENDMENT

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated September 28, 2000, the period for reply extended
by the attached Petition for Extension of Time, please amend the above-identified application as
follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

Page 13, line 16, after "as the under film" insert --102--.

Page 22, line 23, please change "804" to --1204--.

Page 28, line 17, please change "Hbr" to --HBr--.

Page 33, line 1, please change "group 13" to --group IIIA--;

line 14, please change "405" to --402--.

Page 35, line 7, please change "408" to --508--.

02/01/2001 TGEDAMU1 00000080 09352194

01 FC:103

144.00 OP

NVA169035.1

02/15/2001 12:00:00 00000002 00000000 09352194

54.00 OP

02/15/2001 12:00:00

RECEIVED
FEB-6 2001
TC 2000 MAIL ROOM